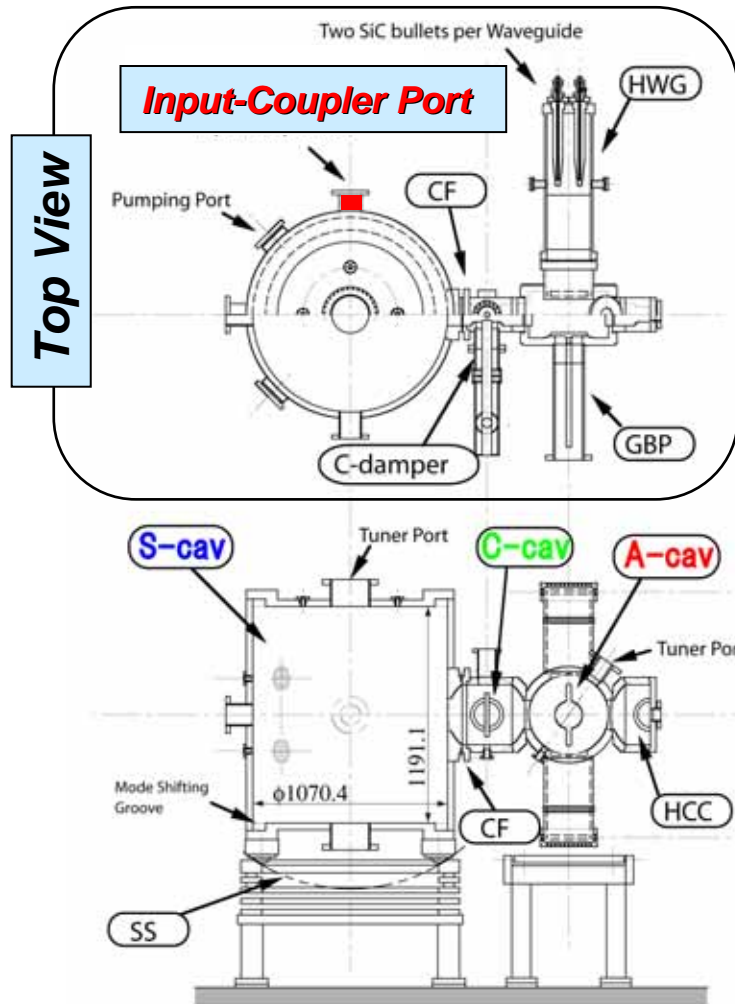


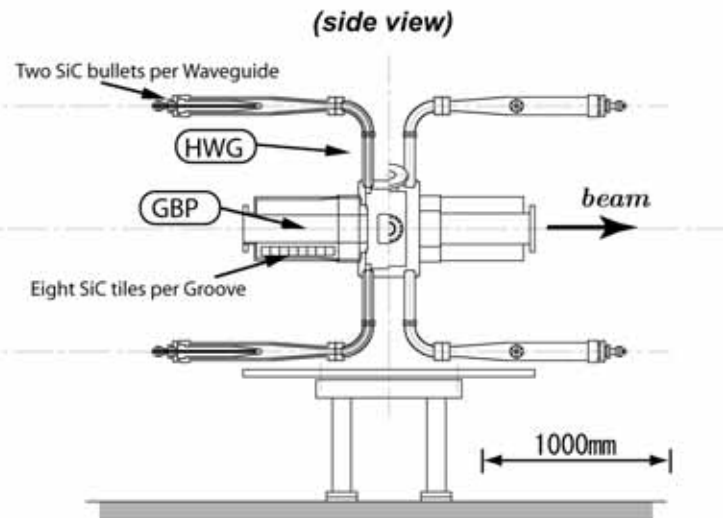
# Accelerator Resonantly-coupled with Energy Storage

## 3-cavity system stabilized with the $\pi/2$ -mode operation

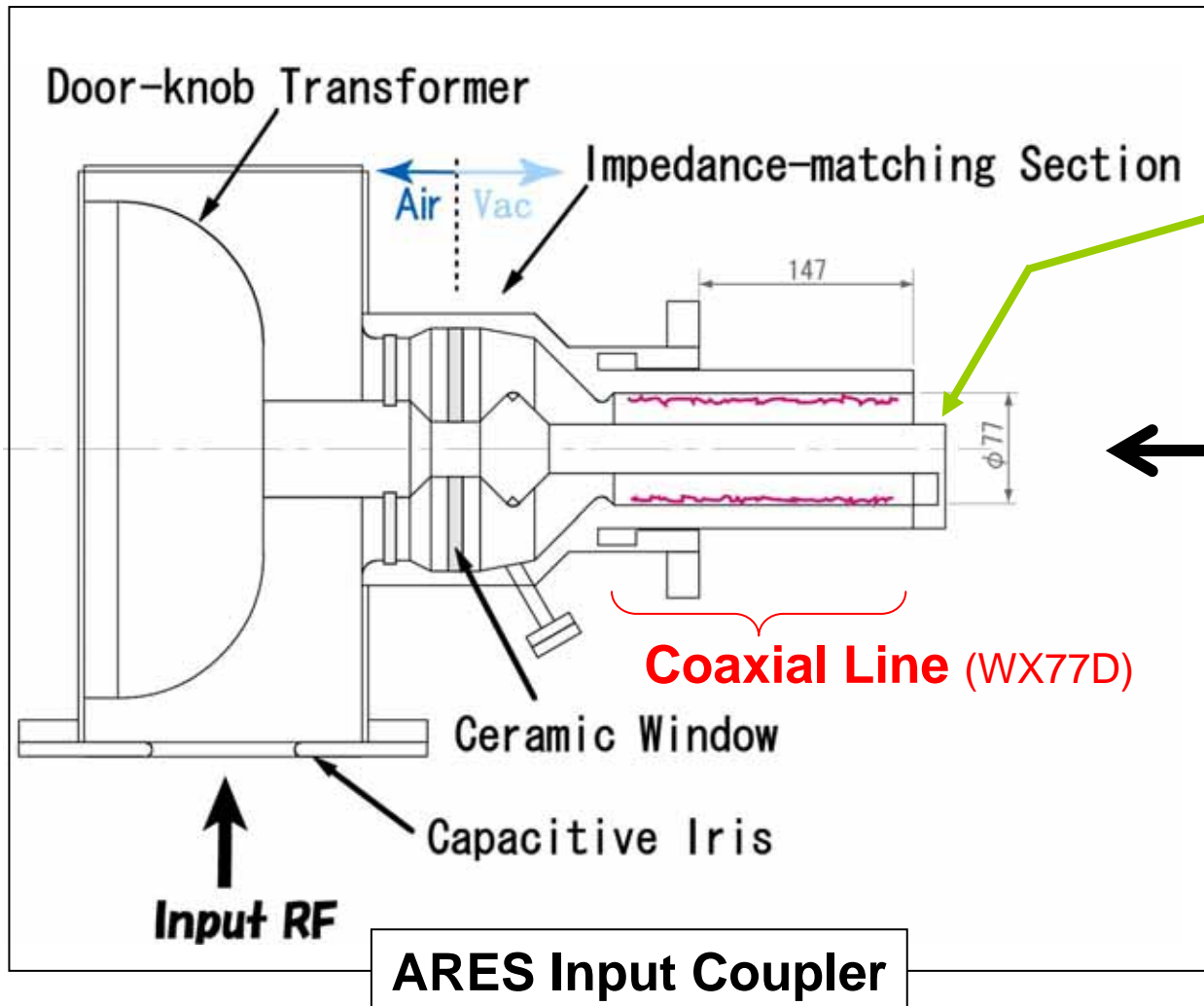


consists of

- HOM-damped accelerating cavity (**A-cav**)
- Energy-storage cavity with TE<sub>013</sub> (**S-cav**)
- Coupling cavity (**C-cav**) with a parasitic-mode damper



The problem is the *multipactoring* in the **coaxial line**.

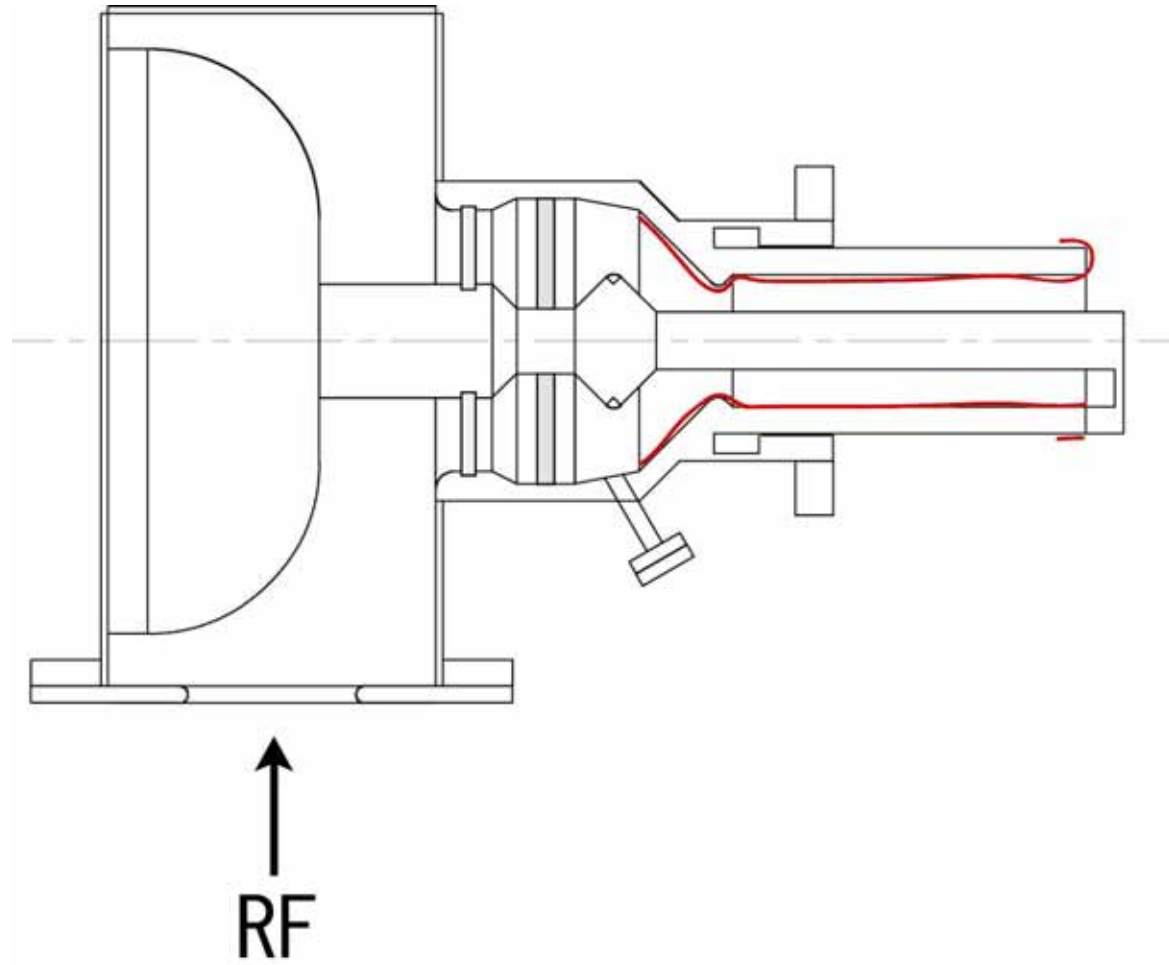


*Coupling Loop*



Example of the TV-camera snapshots of the *multipactoring* in the **coaxial line**

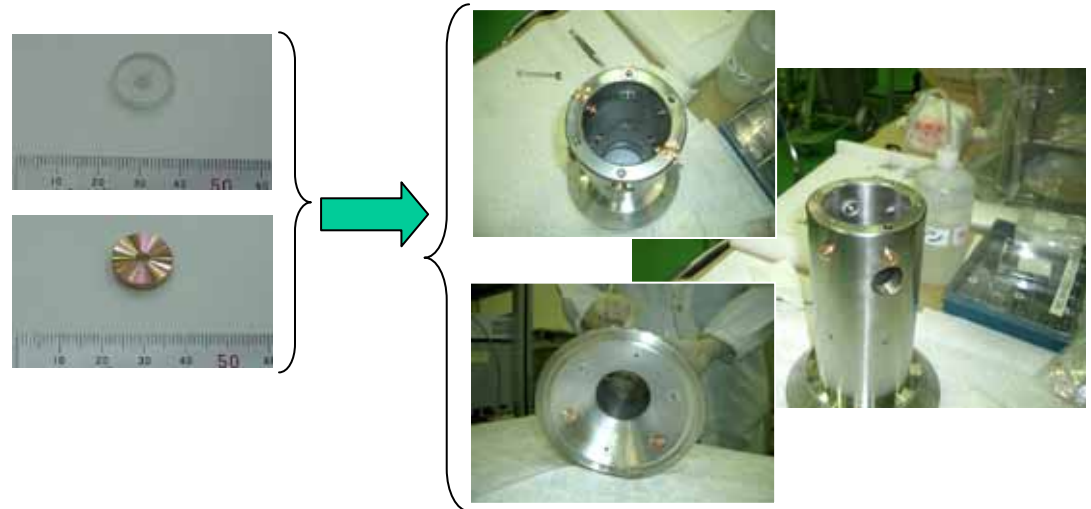
## Coating Area



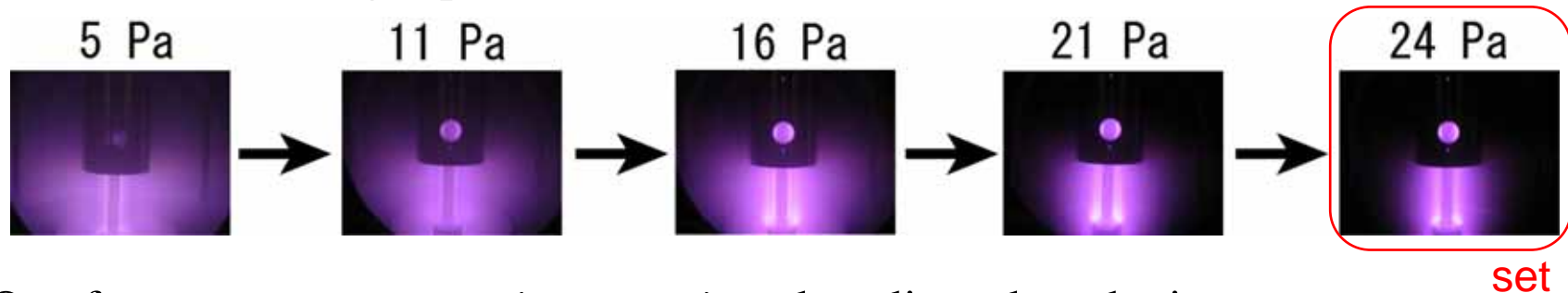
# Study on the TiN coating

✎ Using a dummy conductor and test pieces ( $r=15 \times t3$ ) of

- **Glass** for thickness meas.
- **Copper** for SEY meas.



✎ Increased the total gas pressure (Ar+N<sub>2</sub>)



✎ One free parameter: *gas mixture ratio* to be adjusted to obtain

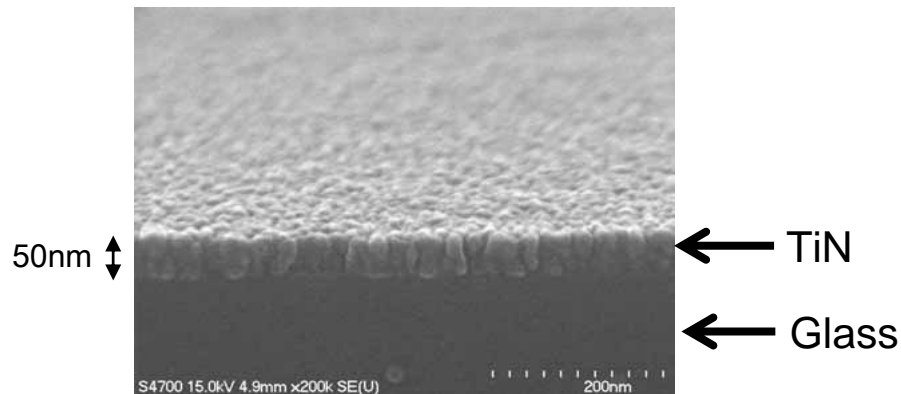
- Appropriate thickness
- Minimum secondary-electron yield (SEY)

# Measurement of TiN Thickness

✎ Using glass test pieces **polished with  $R_a \sim 0.5\text{nm}$**



✎ Done by direct observation of cut samples using **SEM**(x200000)

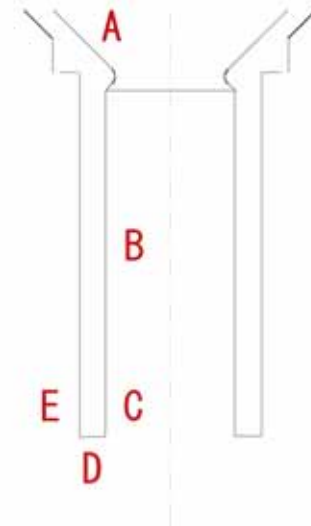
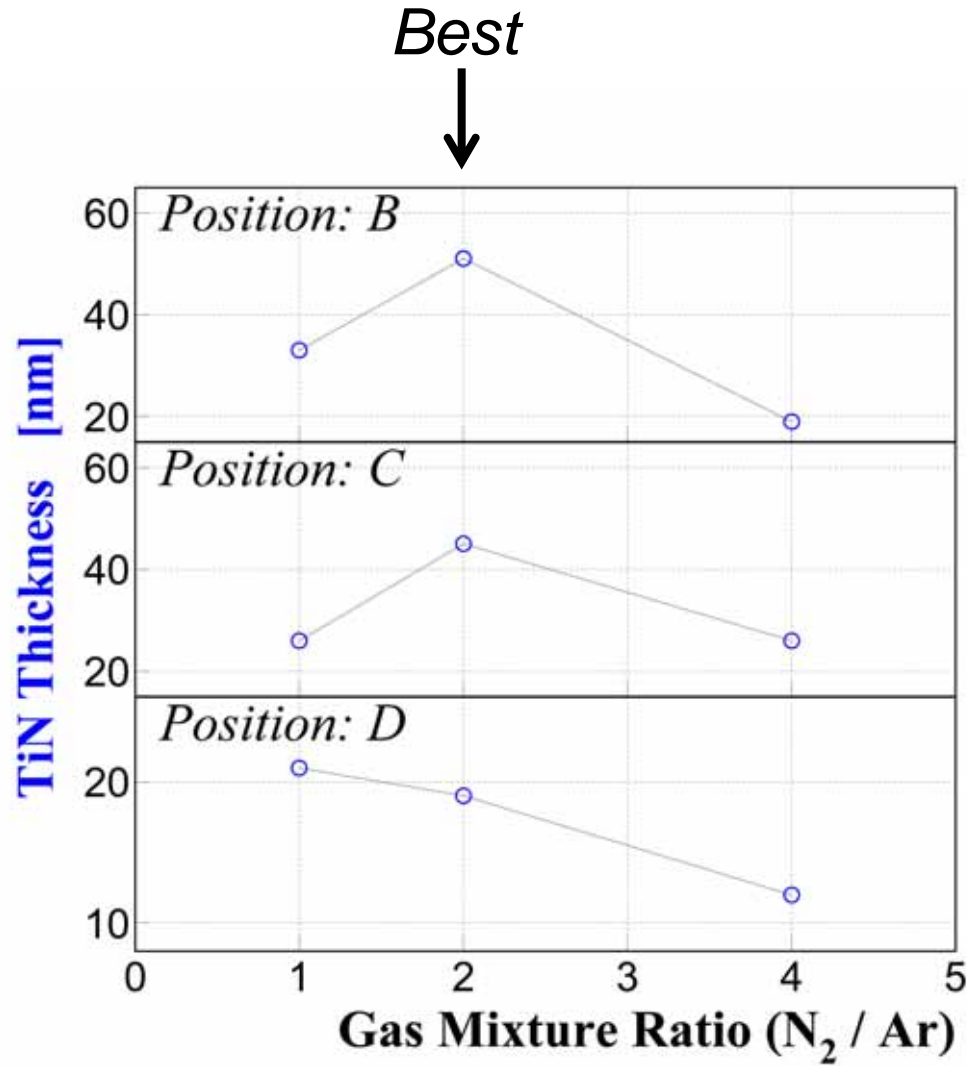


✎ 12 measurements at different positions were averaged.

✎ Minimum requirement: 20nm

- No difference on SEY between 10nm and 20nm
- No increase of SEY of 20nm-coating after brazing (820degC for 5min)

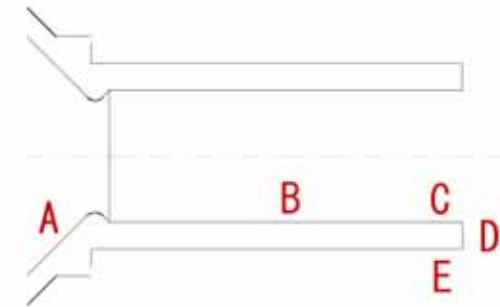
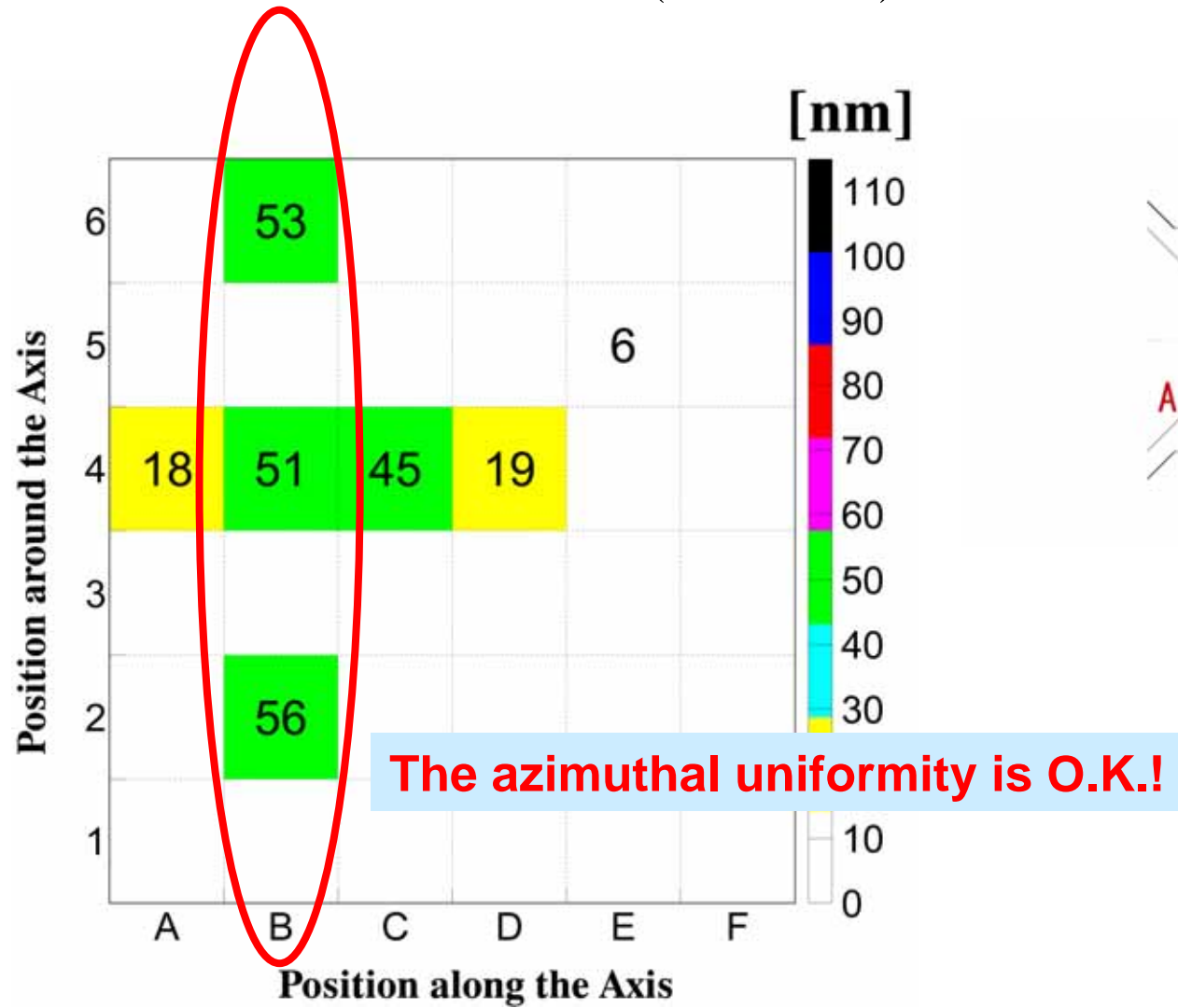
# Results of the TiN-thickness Measurement (1)



- Total 24 Pa fixed
- 40mA kept for 6hrs

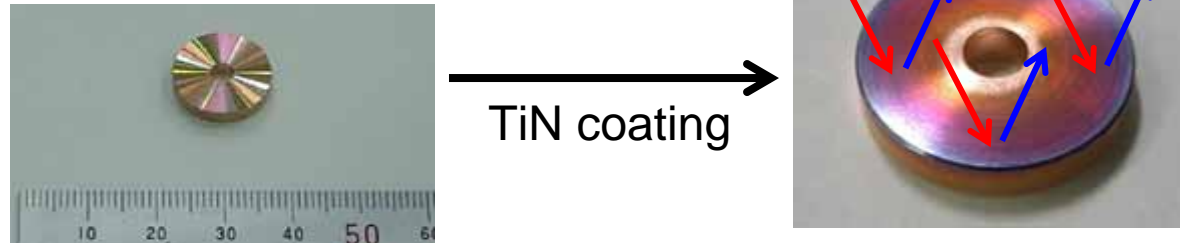
# Results of the TiN-thickness Measurement (2)

(Ar:N<sub>2</sub>=1:2)



# Measurement of Secondary Electron Yield (SEY)

- ✎ Using SEM modified for SEY measurements  
(with the help of S. Michizono)



- ✎ Primary and secondary currents were measured with Faraday cups.

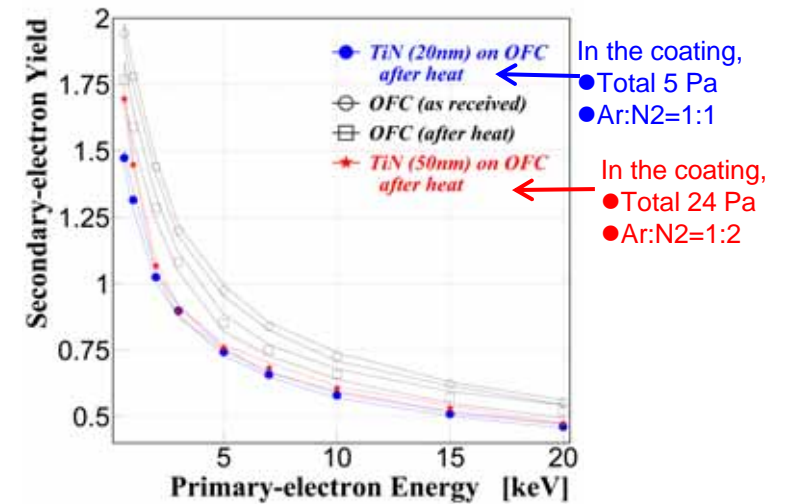
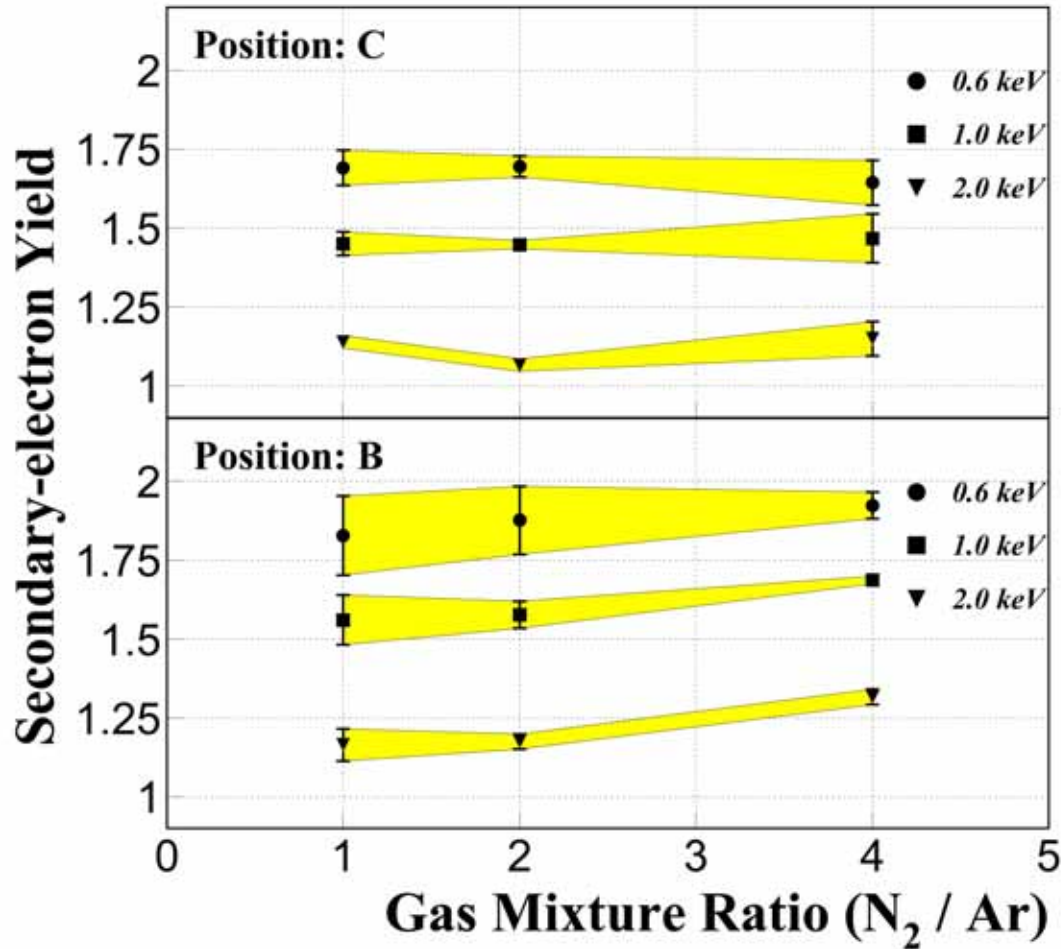
- ✎ SEY definition:  $\delta \stackrel{\text{def}}{=} \frac{\text{Secondary Current including elastically-scattered electrons}}{\text{Primary Current}}$

- ✎ Measurements at 4 different positions were averaged.

- ✎ ~2E-4 Pa during the measurements

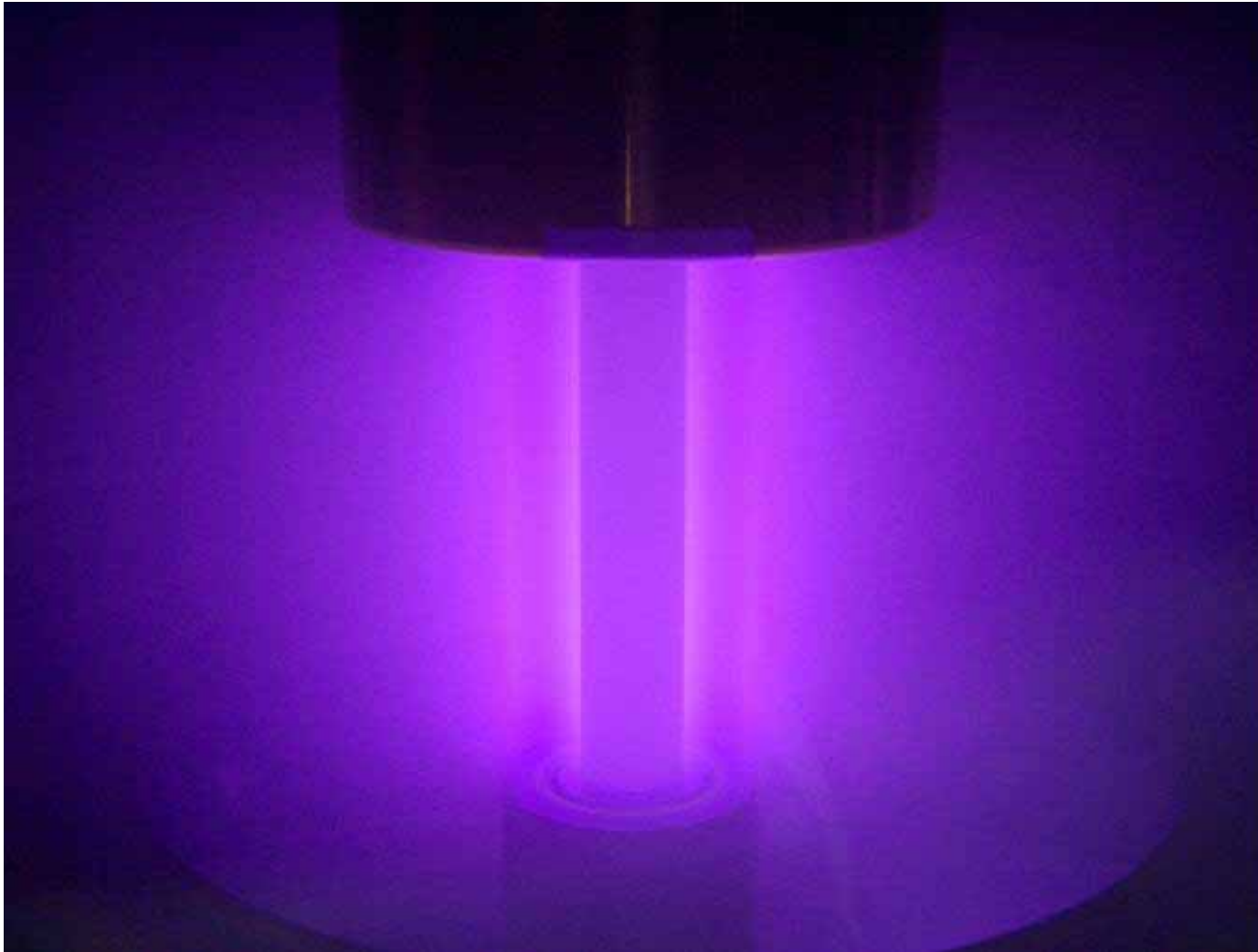


# Results of the SEY Measurements



→ No significant dependence on the gas mixture ratio!

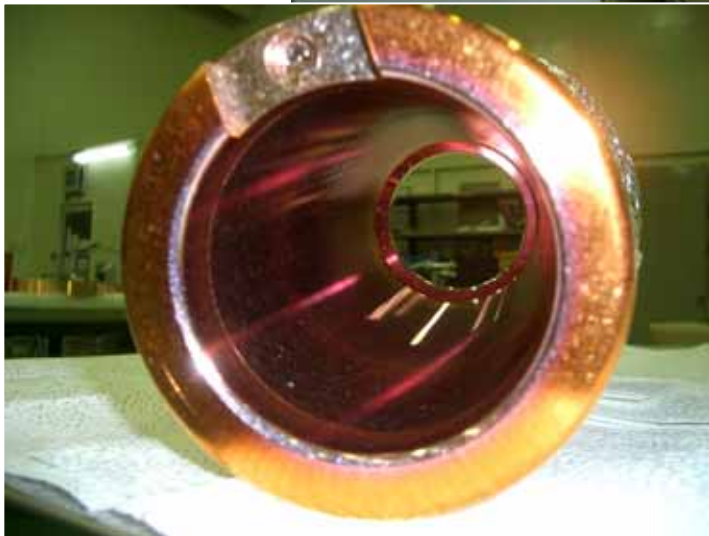
*The TiN coating on the real coupler was done in the final condition.*



# After TiN Coating



Before coating





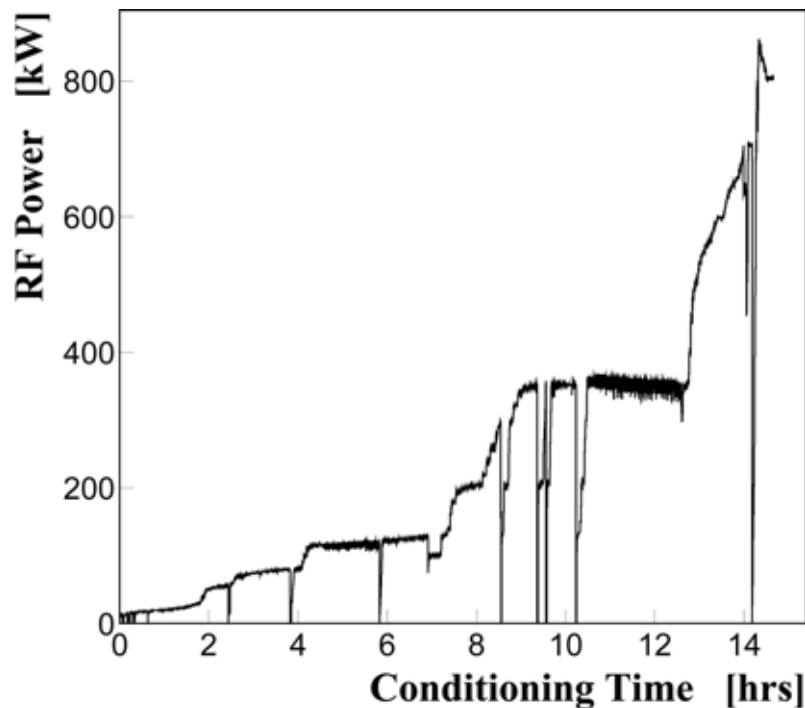
Passed leak tests.



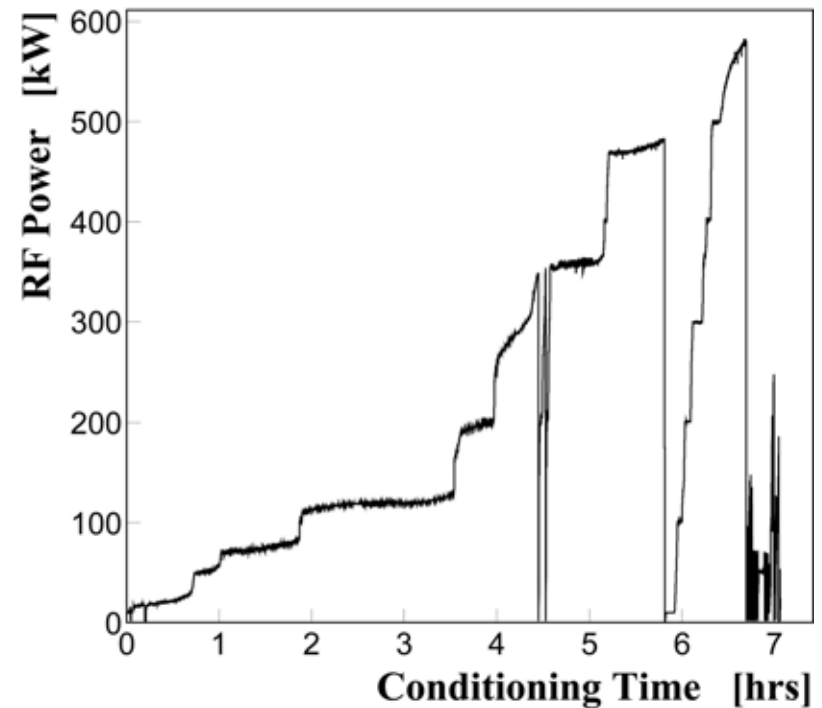
For high power tests...

# High-Power Tests in the upgraded coupler test stand

1<sup>st</sup>-tested TiN-coated coupler



2<sup>nd</sup>-tested TiN-coated coupler



→ No improvement so far compared to non-TiN-coated couplers

# Summary and Conclusions

- TiN coating was applied to the inner surface of the outer conductor.
- Studies were performed in various coating conditions.
- The TiN-coated couplers were tested in the upgraded coupler test stand.
- No significant improvements were seen so far in the conditioning time.
- Further tests are to be done, and alternatives to be considered, e.g. to modify the shape to avoid multipactoring.